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APPLICATION NO.	FILING DATE		FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/091,373 03/04/2002		Hiroshi Ito	ARC920010125US1	7246		
7590 05/01/2006				EXAMINER		
J. Elin Hartrui REED & ASSO				WALKE, AN	MANDA C	
Suite 210	CIATES			ART UNIT	PAPER NUMBER	
800 Menlo Ave				1752		
Menlo Park, CA 94025				DATE MAILED: 05/01/2006		

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)							
	10/091,373	ITO, HIROSHI							
Office Action Summary	Examiner	Art Unit							
	Amanda C. Walke	1752							
The MAILING DATE of this communication app Period for Reply		•							
A SHORTENED STATUTORY PERIOD FOR REPLY WHICHEVER IS LONGER, FROM THE MAILING DA - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory period w. - Failure to reply within the set or extended period for reply will, by statute, Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICATION 36(a). In no event, however, may a reply be time will apply and will expire SIX (6) MONTHS from cause the application to become ABANDONE!	. ely filed the mailing date of this communication. O (35 U.S.C. § 133).							
Status									
1) Responsive to communication(s) filed on <u>17 Ar</u>	<u>oril 2006</u> .								
, —	action is non-final.								
3) Since this application is in condition for allowan	nce except for formal matters, pro	secution as to the merits is							
closed in accordance with the practice under E	x parte Quayle, 1935 C.D. 11, 45	3 O.G. 213.							
Disposition of Claims									
4) Claim(s) 1-31 is/are pending in the application.									
4a) Of the above claim(s) is/are withdray	vn from consideration.								
5) Claim(s) is/are allowed.									
6)⊠ Claim(s) <u>1-31</u> is/are rejected.									
7) Claim(s) is/are objected to.		·							
8) Claim(s) are subject to restriction and/or	r election requirement.	•							
Application Papers									
9) The specification is objected to by the Examine	r.								
10) The drawing(s) filed on is/are: a) acce	epted or b) objected to by the E	Examiner.							
Applicant may not request that any objection to the	drawing(s) be held in abeyance. See	e 37 CFR 1.85(a).							
Replacement drawing sheet(s) including the correct									
11) ☐ The oath or declaration is objected to by the Ex	aminer. Note the attached Office	Action or form PTO-152.							
Priority under 35 U.S.C. § 119									
12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of:)-(d) or (f).							
1. Certified copies of the priority documents2. Certified copies of the priority documents		on No							
3. Copies of the certified copies of the prior application from the International Bureau	•	in this National Stage							
* See the attached detailed Office action for a list		ed.							
Attachment(s) 1) Notice of References Cited (PTO-892)	4) Interview Summary	(PTO-413)							
2) Notice of Preferences Cited (P10-992) Notice of Draftsperson's Patent Drawing Review (PT0-948)	Paper No(s)/Mail Da	nte							
3) X Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08)	· =	atent Application (PTO-152)							
Paper No(s)/Maii Date	Paper No(s)/Mail Date 6) Uther:								

Application/Control Number: 10/091,373

Art Unit: 1752

DETAILED ACTION

Response to Arguments

1. Applicant's arguments, filed 4/17/2006, with respect to the rejection(s) of claim(s) 1-31 under U.S.C. 103 have been fully considered and are persuasive. Therefore, the rejection has been withdrawn. However, upon further consideration, a new ground(s) of rejection foolows...

Claim Rejections - 35 USC § 103

- 2. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 3. Claims 1-31 are rejected under 35 U.S.C. 103(a) as being unpatentable over Araki et al (6,908,724).

Araki et al disclose a fluorine-containing polymer for use as a chemically amplified photoresist. The polymer includes a variety of polymers and monomers, and may take the structure: M1-M2-M3-N, wherein M1 is of structure similar to the instant monomer II (see column 147-149), M2 is an alicyclic monomer, M3 is of structure similar to that of the instant monomer I (see column 158-159), and N is selected from monomers such as ethylene, vinyl ether, allyl, or the monomers described in columns 39-41 which are suitable to be combined with the novel fluorine-containing monomers (claim 16). The monomers described in columns 147-149 and 158-159 comprise groups falling within the scope of the instant claims 2-14. The compositions further comprises an acid generator (such as an onium salt as described in columns 62-93), and is a UV, specially VUV resist (157 nm; see abstract). Also, a solvent, an organic

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base, and optionally a crosslinker should the resist be a negative resist. The resist is then employed in a conventional method of forming a resist pattern columns 94-96 and examples in columns 215-219).

Given the teachings of the references, it would have been obvious to one of ordinary skill in the art to prepare the material of Araki et al choosing to employ the M1-M2-M3-N polymer either alone, or in combination with an additional novel polymer taught by the reference, which comprises monomers meeting the structural limitations of the instant monomers I and II, with reasonable expectation of achieving a material having high etching resistance.

Conclusion

4. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. Takechi et al (6,329,125), Hatakeyama et al (6,835,524), and Ito et al (6,548,219) are cited for their teachings of similar monomers.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Amanda C. Walke whose telephone number is 571-272-1337. The examiner can normally be reached on M-R 5:30-4.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Cynthia Kelly can be reached on 571-272-1526. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Amanda C Waite Amanda C Walke Primary Examiner Art Unit 1752

ACW April 28, 2006

				Complete if Known			
INFORMATION DISCLOSURE				Application Number	10/091,373		
TAIT		N DISCLO	OF PE	Filing Date	March 4, 2002		
1171	URIVIATIO	N DISCLO	SURE &	First Named Inventor	Hiroshi ITO		
ST	ATEMENT			Art Unit	1752		
	(use as many s	heets as necessar <u>k)</u>	FEB 2 7 2006	Examiner Name	Amanda C. Walke		
Sheet	1	of	a 1	Attorney Docket Number	ARC920010125US1		
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U.S. PAPENT DOCUMENTS									
Examiner Initials*	Cite No.	Document Number	Issue Date or Publication Date	Name of Patentee or Applicant of Cited Document	Class	Subclass	Filing Date if Appropriate		
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		FOREIG	N PATENT DOCUMEN'	TS			
Examiner Initials*	Cite No.	Foreign Patent Document No.	Publication Date	Country	Class	Subclass	Т
ACW	AV	JP 2001-154362	6/8/01	Japan			X
ari	AW	JP 2003-212915	7/30/03	Japan		1	X
ww	AX	JP 2003-040926	2/13/03	Japan			X
ACW	AY	WO 02/069038	9/6/02	PCT			

OTHER DOCUMENTS — NONPATENT LITERATURE DOCUMENTS							
Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), Title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	Т				
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Date Examiner Signature Character Considered April 27, 2006
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

					Application/Co	ontrol No.	Applicant(s)/	Patent Under	
		Notice of Reference	s Cited		10/091,373		ITO, HIROSI		
		Motice of Velerence	3 Oneu		Examiner		Art Unit	Page 1 of 1	
					Amanda C. W	alke	1752	Page 1011	
				U.S. P	ATENT DOCUME	NTS			
*		Document Number Country Code-Number-Kind Code	Date MM-YYYY			Name		Classification	
*	Α	US-6,329,125	12-2001	Takech	ni et al.	430/326			
*	В	US-6,835,524	12-2004	Hatake	yama et al.			430/270.1	
*.	С	US-6,548,219	04-2003	Ito et al	I.			430/270.1	
*	D	US-6,908,724	06-2005	Araki e	t al.			430/270.1	
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.